

10/505198
Internal Application No

INTER JONAL SEARCH REPORT

PCT/US 03/07264

a. classification of subject matter IPC 7 G01N23/225 G01N23/203 H01L21/66

DT09 Rec'd PCT/PTO 19 AUG 2004

According to International Patent Classification (IPC) or to both national classification and IPC

## B. FIELDS SEARCHED

Town DOTHOL BIO (second about 1 lists 4000)

 $\begin{array}{ll} \mbox{Minimum documentation searched} \ \ \mbox{(classification system followed by classification symbols)} \\ \mbox{IPC 7} \ \ \ \mbox{G01N} \ \ \mbox{H01L} \\ \end{array}$ 

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC, COMPENDEX

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 5 466 934 A (ADAMS BRENT L ET AL) 14 November 1995 (1995-11-14)	1-3,7, 30-32,37
Y	column 2, line 66 - column 8, line 8	6,36
<b>(</b>	US 5 557 104 A (FIELD DAVID P ET AL) 17 September 1996 (1996-09-17) column 2, line 66 - column 6, line 51	1-3, 30-32
(	MCINTOSH J: "Using CD-SEM metrology in the manufacture of semiconductors" JOM, MARCH 1999, MINERALS, METALS & MATER. SOC, USA, vol. 51, no. 3, March 1999 (1999-03), pages 38-39, XP001153203 ISSN: 1047-4838	1,4,5, 30,33-35
	page 38	
	-/	

X Further documents are listed in the continuation of box C.	Y Patent family members are listed in annex.
"A" document defining the general state of the art which is not considered to be of particular relevance  "E" earlier document but published on or after the international filing date  "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)  "O" document referring to an oral disclosure, use, exhibition or other means  "P" document published prior to the international filing date but later than the priority date claimed	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention  "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone  "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.  "8" document member of the same patent family
Date of the actual completion of the international search	Date of mailing of the international search report
4 November 2003	<b>0</b> 2. 04. <b>2004</b>
Name and mailing address of the ISA	Authorized officer
European Patent Office, P.B. 5818 Patentlaan 2 NL - 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo ni, Fax: (+31-70) 340-3016	Huenges, A



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C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT					
Category ° Citation of docu	ment, with Indication, where appropriate, of the relevant passages	Relevant to claim No.			
uniformechan pre- a JOURNA PART A YORK, vol. 1 July 2 XP0022	8, no. 4, pt 1-2, 000 (2000-07), pages 1287-1296, 17674 0734-2101	4,5			
AND ME THE US MICROB INC., 649-65	T M H ET AL: "IN-PROCESS INSPECTION TROLOGY OF SEMICONDUCTOR WAFERS WITH E OF AN AUTOMATED LOW-VOLTAGE SEM" EAM ANALYSIS, SAN FRANCISCO PRESS SAN FRANCISCO, CA, US, 1986, pages 2, XP000567217 1061-3420 49	4,5			
2 Octo	98 470 B1 (BREINER LYLE ET AL) ber 2001 (2001-10-02) 6, line 44 - column 7, line 38	4,5			
MEASUR METALL MATERI PROCEE PITTSB vol. 3 pages	L ET AL: "MICROTEXTURE EMENTS OF ALUMINUM VLSI IZATION" ALS RESEARCH SOCIETY SYMPOSIUM DINGS, MATERIALS RESEARCH SOCIETY, URG, PA, US, 91, 17 April 1995 (1995-04-17), 347-352, XP000992306 0272-9172 47 - page 348; figure 1	6,36			
-MITSU	27 659 A (SEIKO INSTR INC BISHI ELECTRIC CORP (JP)) ust 1996 (1996-08-21) 1	7,37			



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Box I Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)
This International Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:
Claims Nos.:     because they relate to subject matter not required to be searched by this Authority, namely:
Claims Nos.:     because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful International Search can be carried out, specifically:
3. Claims Nos.: because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).
Box II Observations where unity of invention is lacking (Continuation of item 2 of first sheet)
This International Searching Authority found multiple inventions in this international application, as follows:
see additional sheet
As all required additional search fees were timely paid by the applicant, this International Search Report covers all searchable claims.
2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
3. As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.:
Concequently, this International Search Report is
4. No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.:  1-7, 30-37
The state of the s
Remark on Protest  The additional search fees were accompanied by the applicant's protest.  No protest accompanied the payment of additional search fees.

## INTERNATIONAL SEARCH REPORT

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## FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

This International Searching Authority found multiple (groups of) inventions in this international application, as follows:

1. claims: 1-7,30-37

Scanning electron microscope (SEM) adapted to generate crystallographic data from different grains within the crystalline sample; method of using the apparatus.

2. claims: 8-14,38-49

Focused ion beam (FIB) apparatus adapted to provide a contrast image; method of using the apparatus.

3. claims: 15-22,50-60

Combined SEM and FIB apparatus adapted to provide a contrast image and crystallographic data from different grains within the sample; method of using the apparat.

4. claims: 23-29

Crystallographic standard sample for ion channeling analysis of a crystalline sample.



Interval al Application No PCT/US 03/07264

-Patent document cited in search report	•	Publication date		Patent family member(s)	Publication date
US 5466934	Α	14-11-1995	NONE		
US 5557104	Α	17-09-1996	AU WO	7463596 A 9715824 A1	15-05-1997 01-05-1997
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EP 0727659	A	21-08-1996	JP JP EP US US	2813147 B2 8220005 A 0727659 A2 6355495 B1 6124142 A	22-10-1998 30-08-1996 21-08-1996 12-03-2002 26-09-2000

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